

# Magnetic Stimulation Probing Solutions

- Magnetic Stimulation Systems (MSS)
  - Magnetic mounting and Stimulation from the topside or backside
  - Single or Multi-Purpose Configurations Available
- Family – Manual and Semiautomatic
- Applications: Spintronics, Hall Effect Devices, Memory and Other
- Thermal Systems – 2 types – Chuck or Thermal Wand
  - Thermal Wand: -20 C to +225 C
  - Thermal Chuck: -60 to 300 C
- Customized Chucks and Carrier Plates for die, substrates, partial wafers and whole wafers to 300 mm
- Available with or without Dark Boxes or Localized Environmental Chambers (LEC)
- Manipulators – manual and programmable with a family of probe arms
- Probe Tips, Probe Cards, Wedges
- Probe Card Holders – 4.5" to 6.0"
- Integrated Solutions with Magnet Suppliers
- Modular PS4L Hardware & Software Architecture

